

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: MS Post Issue, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Dated: December 8, 2004

Signature: _____

(Michael R. Hall)

10630280 *lape*
Docket No.: 29925/39488
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Letters Patent of:

Jae-Han CHA

Patent No.: 6,784,063 *B2*

Issued: August 31, 2004

For: METHOD FOR FABRICATING
BICMOS TRANSISTOR

**Certificate
DEC 20 2004
of Correction**

**REQUEST FOR CERTIFICATE OF CORRECTION
PURSUANT TO 37 CFR 1.322**

MS Post Issue
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Upon reviewing the above-identified patent, Patentee noted a typographical error which should be corrected.

APPLICATION PAGE NO.	APPLICATION LINE NO.	COLUMN NO.	LINE NO.	ERROR
Examiner's Amendment of May 21, 2004	Claim 1 Page 11, Line 10	Claim 1 Column 5	Lines 15-16	PTO

The error was not in the application as filed by applicant; accordingly no fee is required.

DEC 22 2004

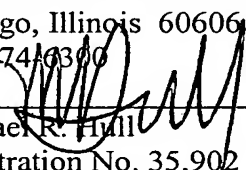
Patent No.: 6,784,063

Docket No.: 29925/39488

Transmitted herewith is a proposed Certificate of Correction effecting such amendment. Patentee respectfully solicits the granting of the requested Certificate of Correction.

Respectfully submitted,
MARSHALL, GERSTEIN & BORUN LLP
6300 Sears Tower
233 South Wacker Drive
Chicago, Illinois 60606
312-474-0300

By:



Michael R. Hull
Registration No. 35,902
Attorney for Applicant

December 8, 2004

791831

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: MS Post Issue, Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450, on the date shown below.

Dated: December 8, 2004

Signature: _____

(Michael R. Hill)

Docket No.: 29925/39488
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Letters Patent of:

Jae-Han CHA

Patent No.: 6,784,063 *B2*

Issued: August 31, 2004

For: **METHOD FOR FABRICATING
BICMOS TRANSISTOR**

**REQUEST FOR CERTIFICATE OF CORRECTION
PURSUANT TO 37 CFR 1.322**

MS Post Issue
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Upon reviewing the above-identified patent, Patentee noted a typographical error which should be corrected.

APPLICATION PAGE NO.	APPLICATION LINE NO.	COLUMN NO.	LINE NO.	ERROR
Examiner's Amendment of May 21, 2004	Claim 1 Page 11, Line 10	Claim 1 Column 5	Lines 15-16	PTO

The error was not in the application as filed by applicant; accordingly no fee is required.

DEC 22 2004

Transmitted herewith is a proposed Certificate of Correction effecting such amendment. Patentee respectfully solicits the granting of the requested Certificate of Correction.

Respectfully submitted,
MARSHALL, GERSTEIN & BORUN LLP
6300 Sears Tower
233 South Wacker Drive
Chicago, Illinois 60606
312-474-6300

By: _____

Michael R. Hull
Registration No. 35,902
Attorney for Applicant

December 8, 2004

791831

DEC 22 2004

**UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION**

PATENT NO. : 6,784,063 *B2*
DATED : August 31, 2004
INVENTOR(S) : Jae-Han Cha

It is certified that error appears in the above-identified patent and that said Letter's Patent
is hereby corrected as shown below:

**Claim 1
Column 5
Lines 15-16**

After "forming a nitride film for a spacer on,"
please delete "oxide film 64 for the base spacer;"
and insert -- the structure generated by the above formations; -- in its place.

MAILING ADDRESS OF SENDER:
Michael R. Hull
MARSHALL, GERSTEIN & BORUN LLP
233 S. Wacker Drive, Suite 6300
Sears Tower
Chicago, Illinois 60606-6357

PATENT NO. 6,784,063

No. of additional copies 3

DEC 22 2004

Application No. (if known): 10/630,280

Attorney Docket No.: 29925/39488

Certificate of Mailing under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

MS Post Issue
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

on December 8, 2004

Date



Signature

Michael R. Hull

Typed or printed name of person signing Certificate

35,902

Registration Number, if applicable

(312) 474-9577

Telephone Number

Note: Each paper must have its own certificate of mailing, or this certificate must identify each submitted paper.

Request for Certificate of Correction (No Fee)

**UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION**PATENT NO. : 6,784,063 *B2*

DATED : August 31, 2004

INVENTOR(S) : Jae-Han Cha

It is certified that error appears in the above-identified patent and that said Letters Patent
is hereby corrected as shown below:

**Claim 1
Column 5
Lines 15-16**

After "forming a nitride film for a spacer on,"
please delete "oxide film 64 for the base spacer;"
and insert -- the structure generated by the above formations; -- in its place.

MAILING ADDRESS OF SENDER:

Michael R. Hull

MARSHALL, GERSTEIN & BORUN LLP

233 S. Wacker Drive, Suite 6300

Sears Tower

Chicago, Illinois 60606-6357

PATENT NO. 6,784,063No. of additional copies **3****DEC 22 2004**

**UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION**PATENT NO. : 6,784,063 *B2*

DATED : August 31, 2004

INVENTOR(S) : Jae-Han Cha

It is certified that error appears in the above-identified patent and that said Letters Patent
is hereby corrected as shown below:

**Claim 1
Column 5
Lines 15-16**

After "forming a nitride film for a spacer on,"
please delete "oxide film 64 for the base spacer;"
and insert -- the structure generated by the above formations; -- in its place.

MAILING ADDRESS OF SENDER:

Michael R. Hull
MARSHALL, GERSTEIN & BORUN LLP
233 S. Wacker Drive, Suite 6300
Sears Tower
Chicago, Illinois 60606-6357

PATENT NO. 6,784,063No. of additional copies **3****DEC 22 2004**

**UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION**

PATENT NO. : 6,784,063 *B2*
DATED : August 31, 2004
INVENTOR(S) : Jae-Han Cha

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

**Claim 1
Column 5
Lines 15-16**

After "forming a nitride film for a spacer on,"
please delete "oxide film 64 for the base spacer;"
and insert -- the structure generated by the above formations; -- in its place.

MAILING ADDRESS OF SENDER:

Michael R. Hull
MARSHALL, GERSTEIN & BORUN LLP
233 S. Wacker Drive, Suite 6300
Sears Tower
Chicago, Illinois 60606-6357

PATENT NO. 6,784,063

No. of additional copies 3

DEC 22 2004